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# INDUSTRIAL TECHNOLOGIES IN CLIC

N. CATALAN LASHERAS.

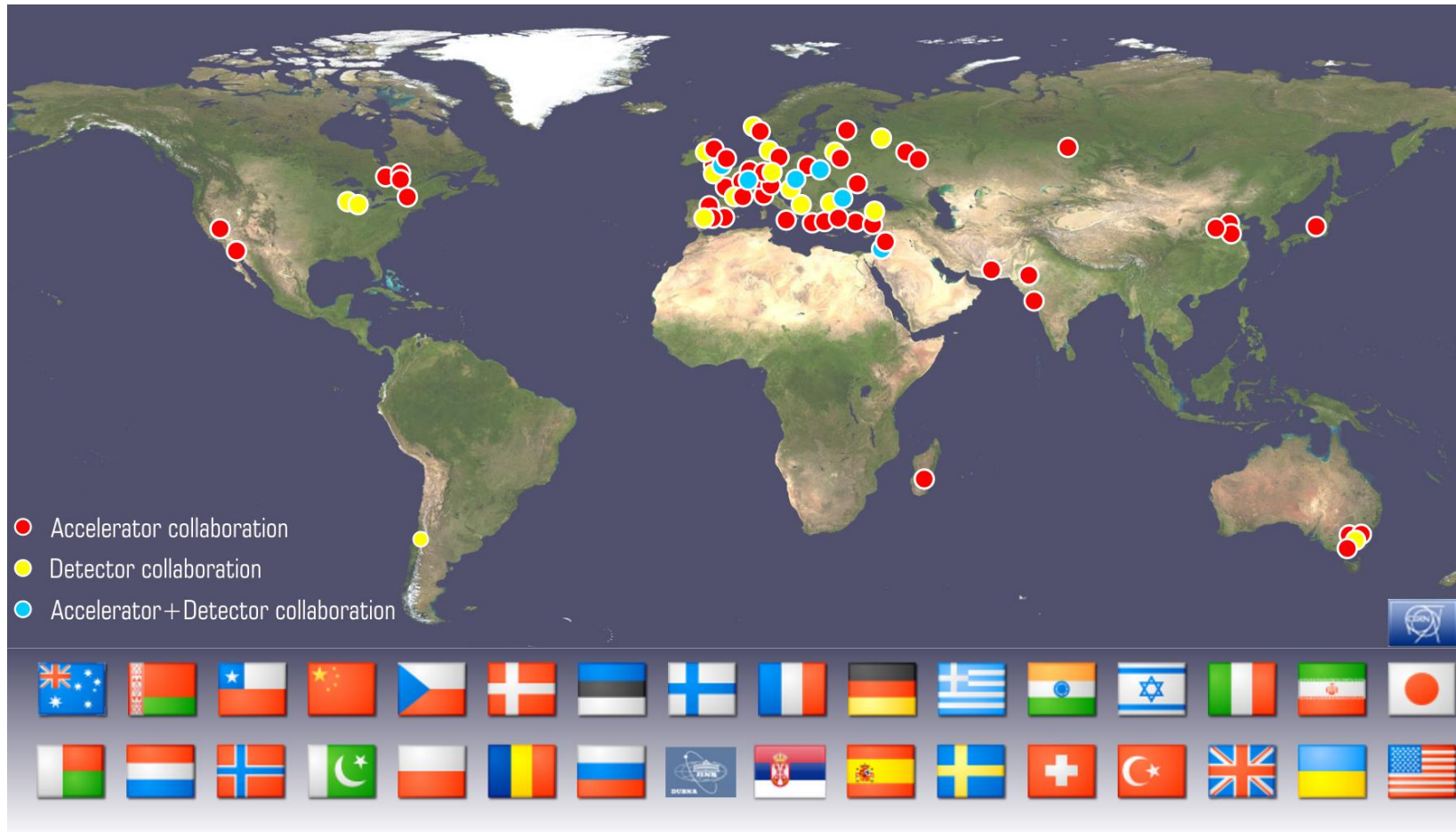




# BRIEF INTRODUCTION TO CLIC



# COLLABORATION



58 institutes from 28 countries





### 2013 - 2019 Development Phase

Development of a Project Plan for a staged CLIC implementation in line with LHC results; technical developments with industry, performance studies for accelerator parts and systems, detector technology demonstrators

### 2020 - 2025 Preparation Phase

Finalisation of implementation parameters, preparation for industrial procurement, Drive Beam Facility and other system verifications, Technical Proposal of the experiment, site authorisation

### 2026 - 2034 Construction Phase

Construction of the first CLIC accelerator stage compatible with implementation of further stages; construction of the experiment; hardware commissioning

### 2019 - 2020 Decisions

Update of the European Strategy for Particle Physics; decision towards a next CERN project at the energy frontier (e.g. CLIC, FCC)

### 2025 Construction Start

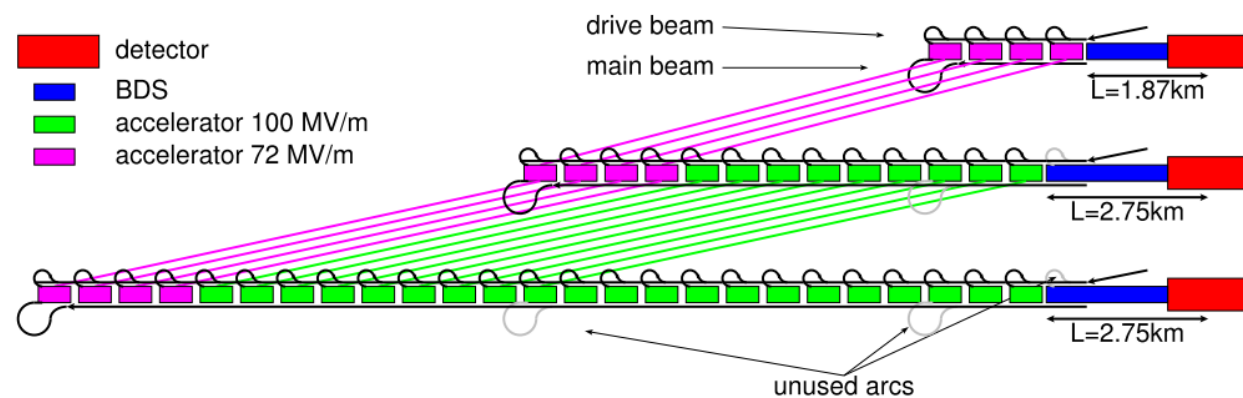
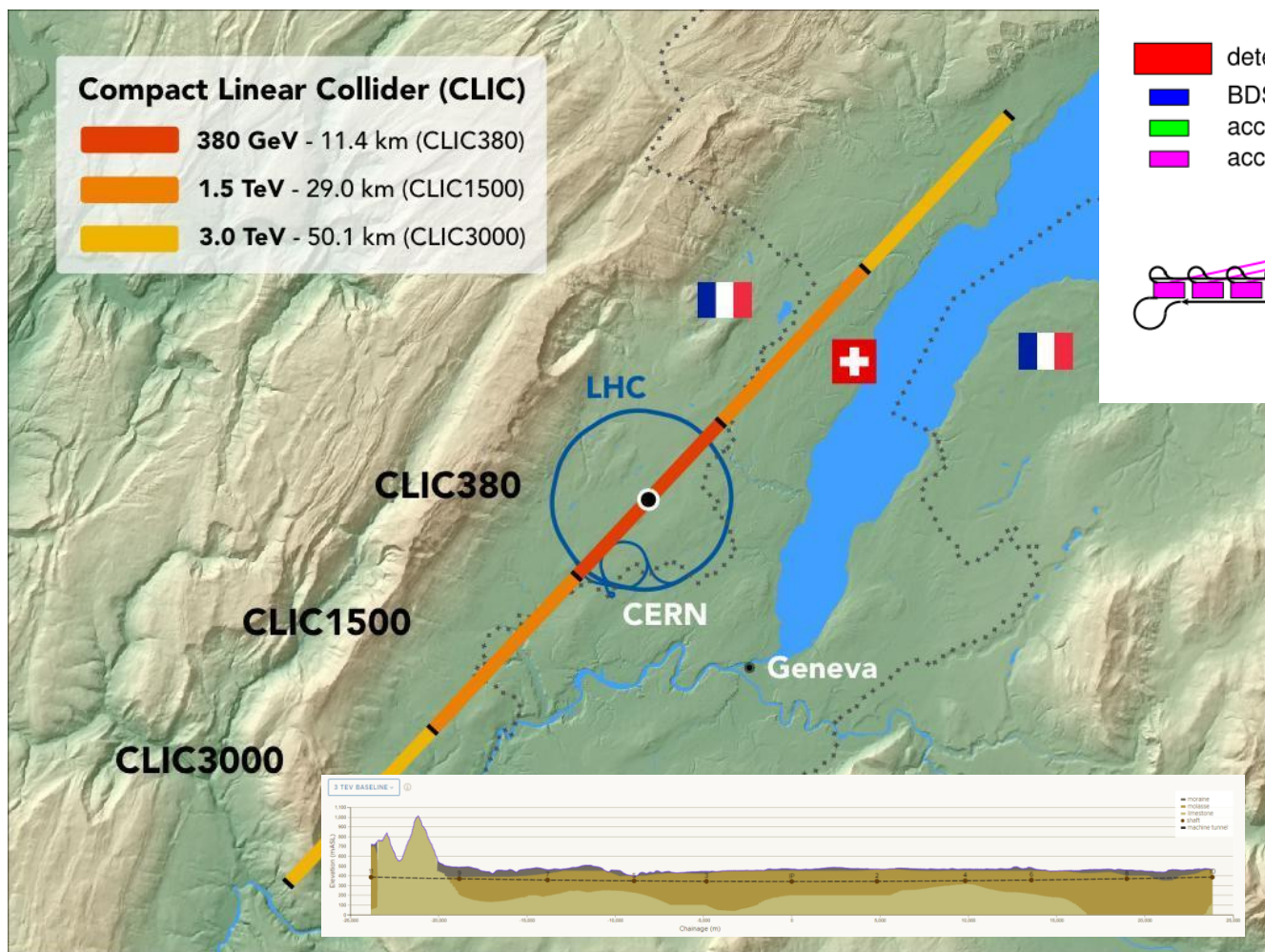
Ready for construction; start of excavations

### 2035 First Beams

Getting ready for data taking by the time the LHC programme reaches completion

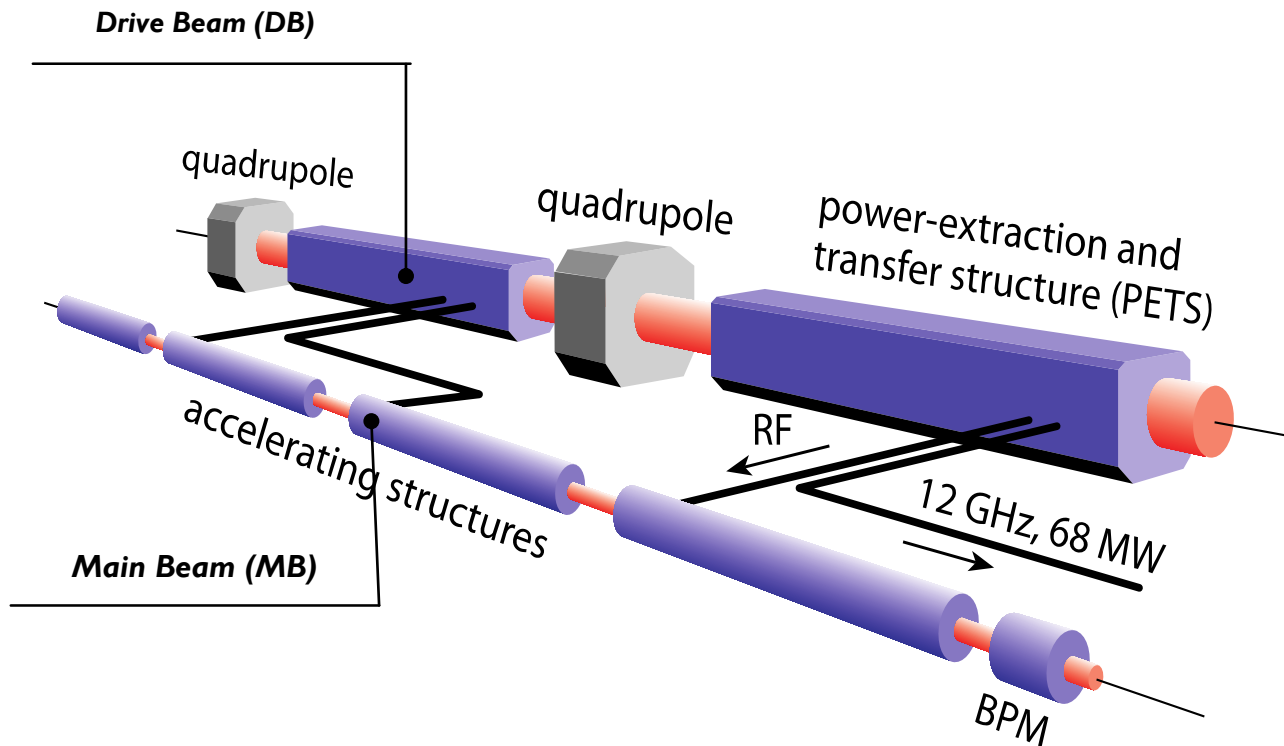


# STAGED CLIC IMPLEMENTATION



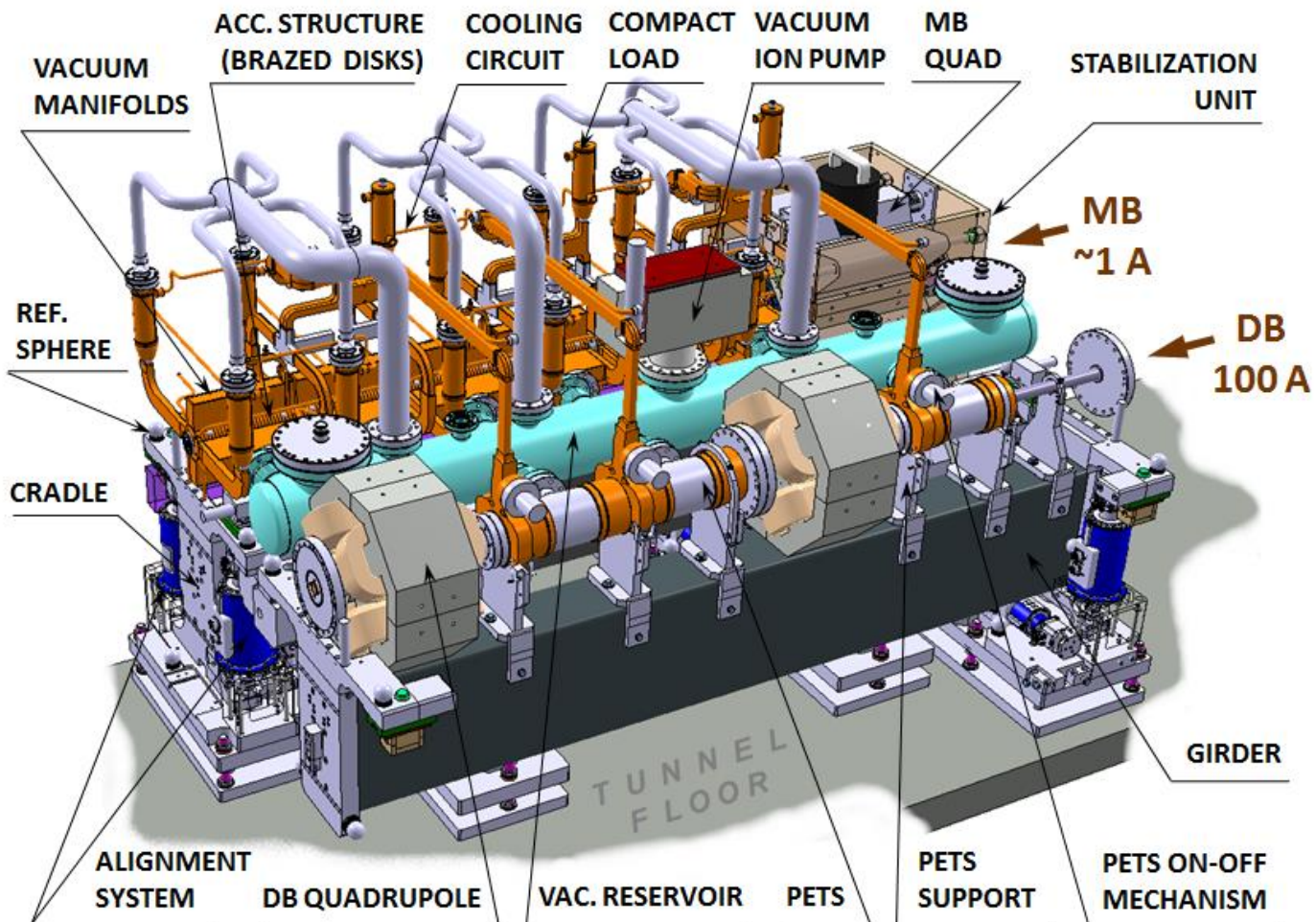
Parameter	Symbol	Unit	Stage 1	Stage 2	Stage 3
Centre-of-mass energy	$\sqrt{s}$	GeV	380	1500	3000
Repetition frequency	$f_{\text{rep}}$	Hz	50	50	50
Number of bunches per train	$n_b$		352	312	312
Bunch separation	$\Delta t$	ns	0.5	0.5	0.5
Pulse length	$\tau_{\text{RF}}$	ns	244	244	244
Accelerating gradient	$G$	MV/m	72	72/100	72/100
Total luminosity	$\mathcal{L}$	$10^{34} \text{ cm}^{-2} \text{ s}^{-1}$	1.5	3.7	5.9
Luminosity above 99% of $\sqrt{s}$	$\mathcal{L}_{0.01}$	$10^{34} \text{ cm}^{-2} \text{ s}^{-1}$	0.9	1.4	2
Main tunnel length		km	11.4	29.0	50.1
Number of particles per bunch	$N$	$10^9$	5.2	3.7	3.7
Bunch length	$\sigma_z$	$\mu\text{m}$	70	44	44
IP beam size	$\sigma_x/\sigma_y$	nm	149/2.9	$\sim 60/1.5$	$\sim 40/1$
Normalised emittance (end of linac)	$\epsilon_x/\epsilon_y$	nm	920/20	660/20	660/20
Normalised emittance (at IP)	$\epsilon_x/\epsilon_y$	nm	950/30	—	—
Estimated power consumption	$P_{\text{wall}}$	MW	252	364	589

# TWO-BEAM PRINCIPLE



The RF power is extracted from a with low energy and high intensity drive beam to be injected in a lower intensity, higher energy electron beam that is made to collide with a second positron beam equally generated

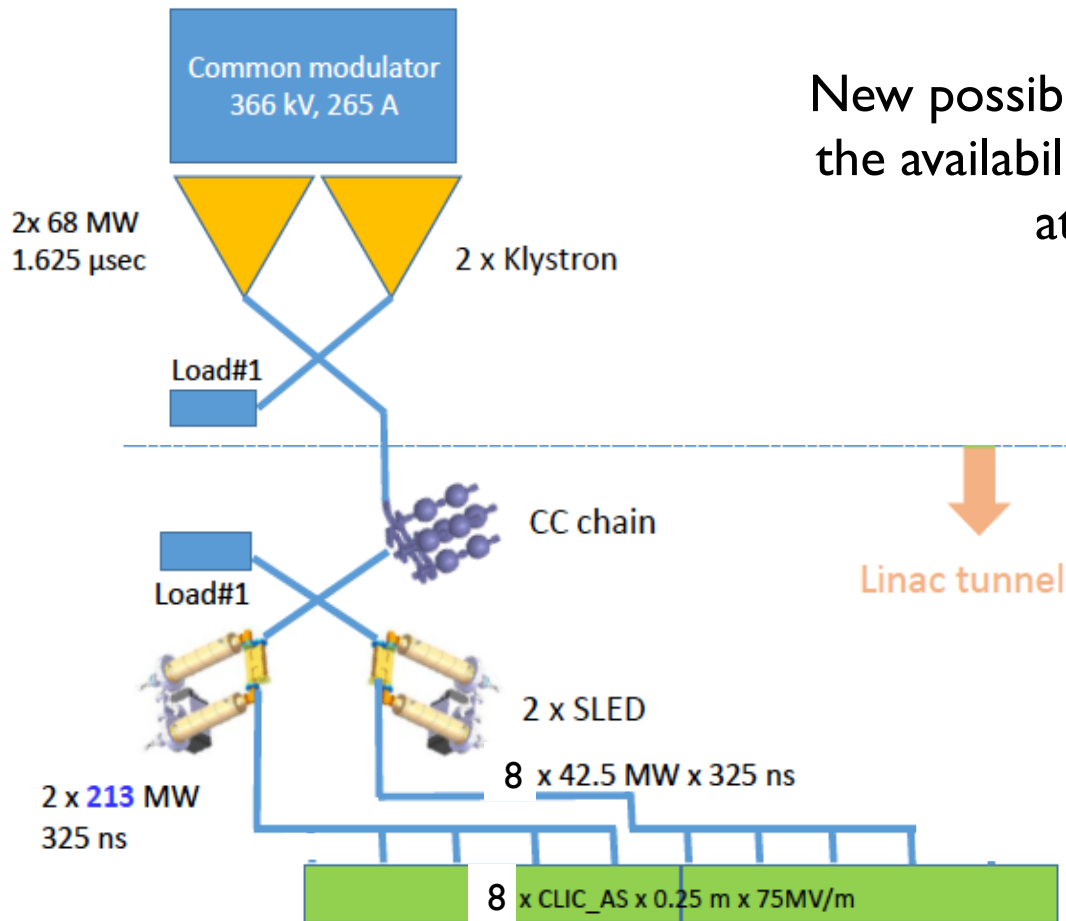
# CLIC MODULE. MAIN PARAMETERS AND COMPONENTS



**Main parameters of CLIC module (>10000)**

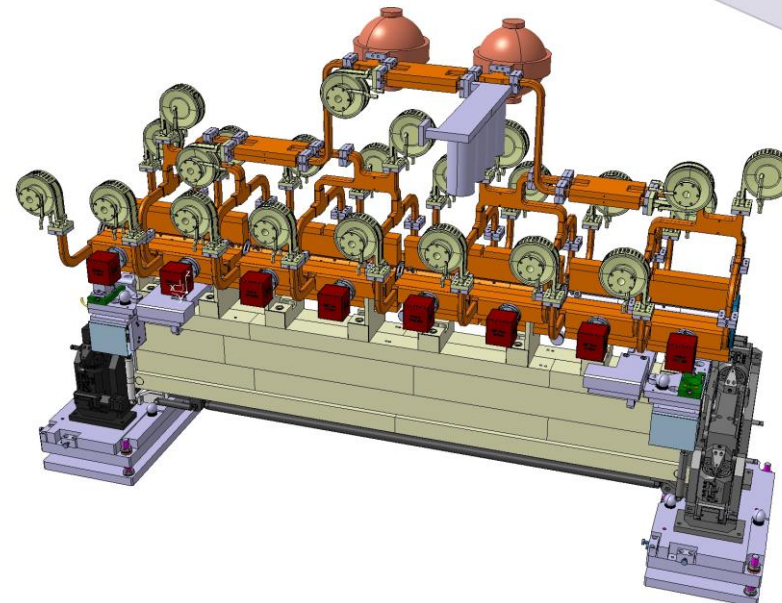
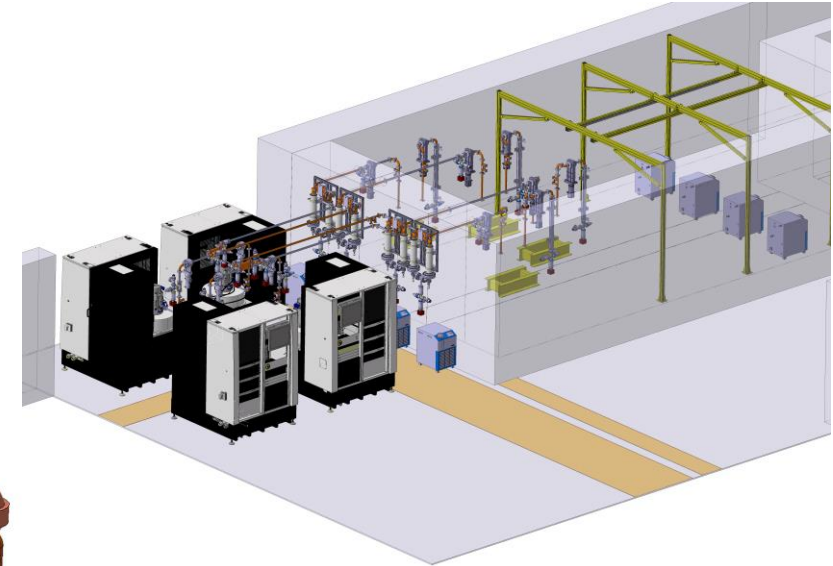
Module length	2010	mm
PETS length	308	mm
PETS aperture	23	Mm
PETS gradient	6.5	MV/m
PETS power	136	MW
AS length	230	mm
AS aperture	5	Mm
AS gradient	100	MV/m
AS power	64	MW
Vacuum level	$10^{-9}$	mbar

# KYSTRON-BASED CLIC AND X-BAND TEST FACILITY.



New possibilities open thanks to  
the availability of power sources  
at 12 GHz!!

Linac tunnel





# CLIC TECHNOLOGIES IN INDUSTRY



# THE NEED FOR QUALIFICATION

## Proven technologies

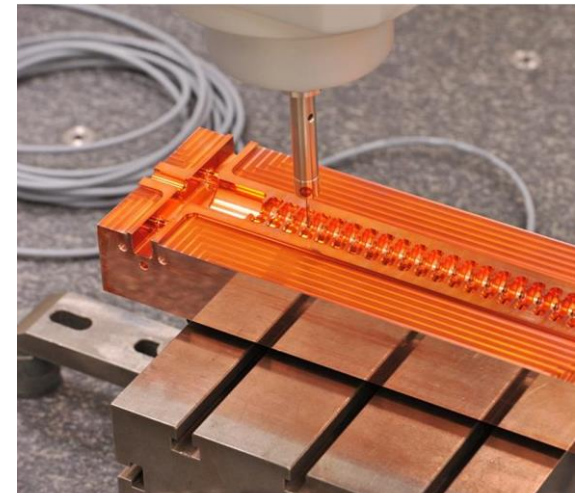
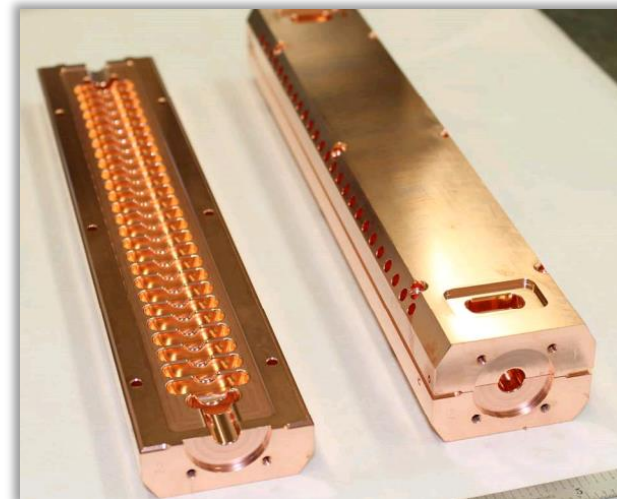
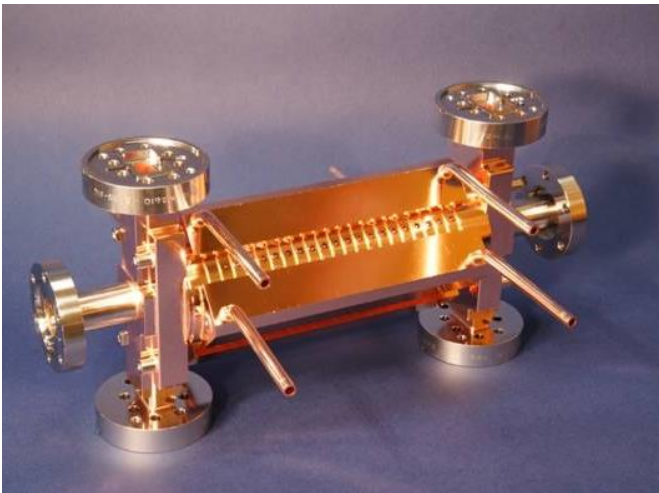
- There are either “off the shelf” products or technologies that have been proven by the manufacturer in previous products.
- The product exist on the company catalogue or can be adapted with a reasonable effort.
- Companies can be included in a call for tender with a technical specification.
- Typically a first unit will be order and subject to a battery of tests to fulfil the tight requirements
- Examples; High voltage modulators, klystrons, ceramics, electronic components, piezo movers, sensors, etc.

## New technologies

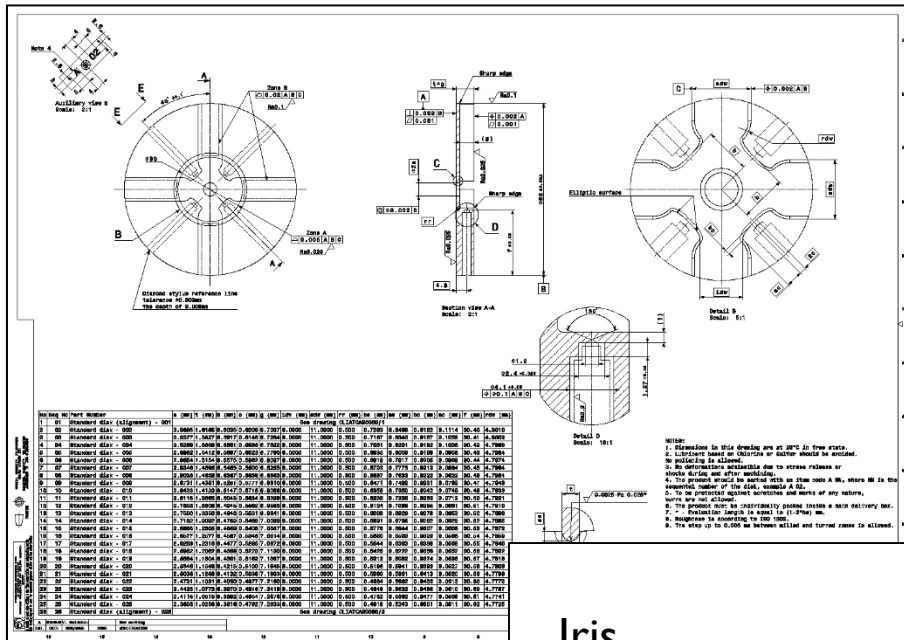
- New, tighter tolerances required
- Stringent constrains on safety, cleanliness, etc.
- Done as prototypes at CERN. Technology transfer is generally required from CLIC side
- **The firm capability to produce the parts needs to be proven through a qualification process**
- **Qualification may consist on visits, the delivery of a test unit or a dedicated test. Qualification documents are available.**
- Examples: Ultra precision machining, hydrogen copper bonding, ultra-high-vacuum components.

# COPPER ULTRA-PRECISION MACHINING I

- Diamond-tool ultraprecision machining
- Turning and milling
- Very strict qualification based on visual inspection and CMM metrology
- VDL (NL), LT-Ultra (DE), Yvon Boyer (FR), DMP (ES), Morikawa (JP), KERN (DE)



# COPPER ULTRA PRECISION MACHINING II



**Cell shape accuracy:**

zone A - 0.005 mm

zone B - 0.02 mm

**Flatness - 0.001 mm**

**Surface roughness:**

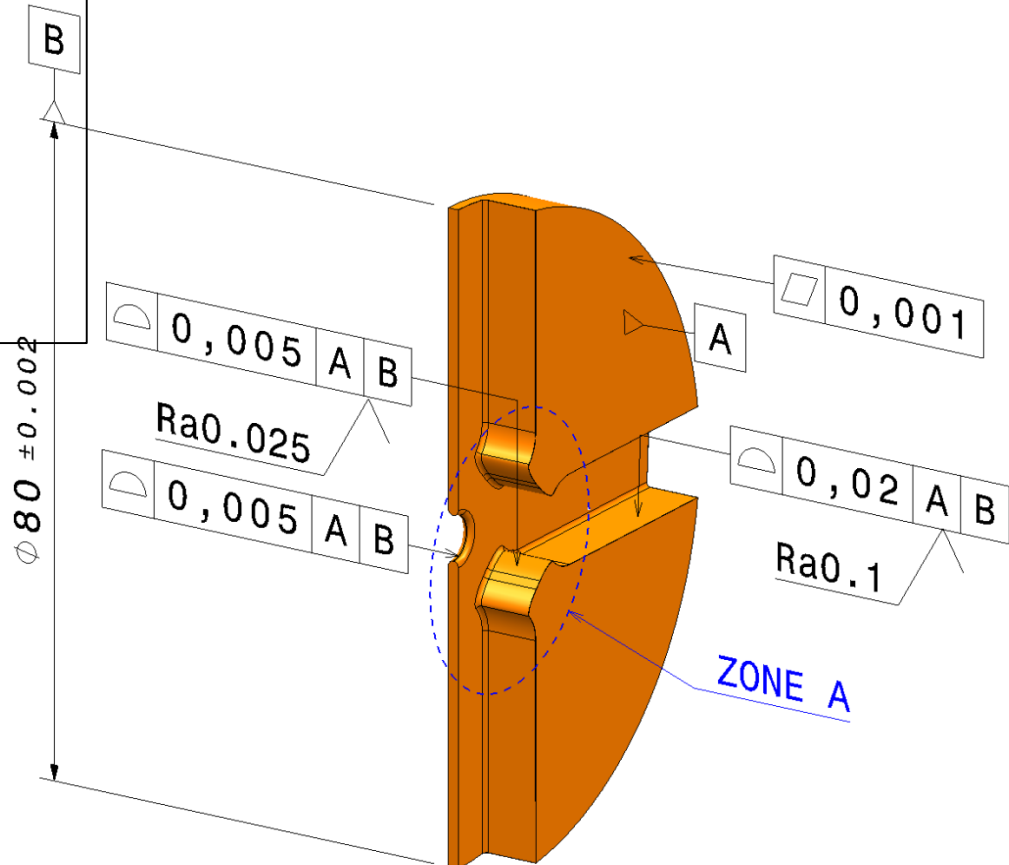
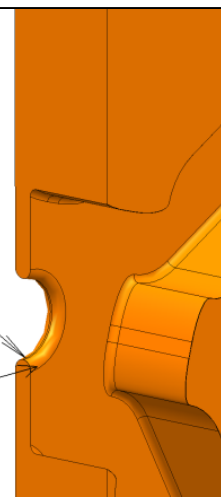
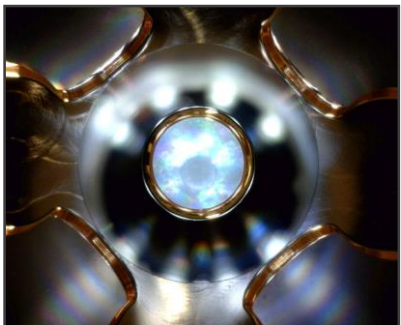
zone A Ra 0.025  $\mu\text{m}$

zone B Ra 0.1  $\mu\text{m}$

Iris

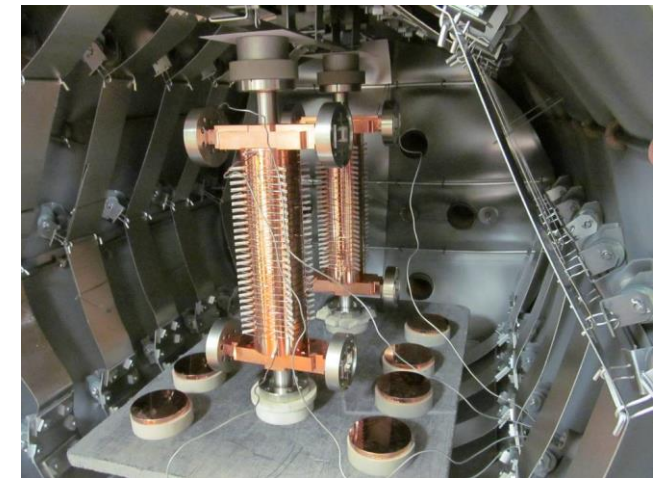
0.0025-Pa0.025\*

0.0025-0.08/Ra1 0.025

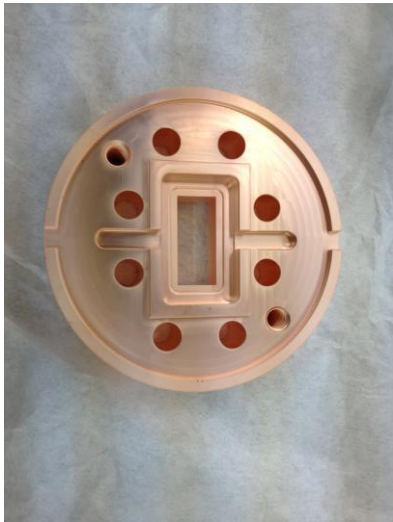


# JOINING. COPPER DIFFUSION BONDING AND BRAZING

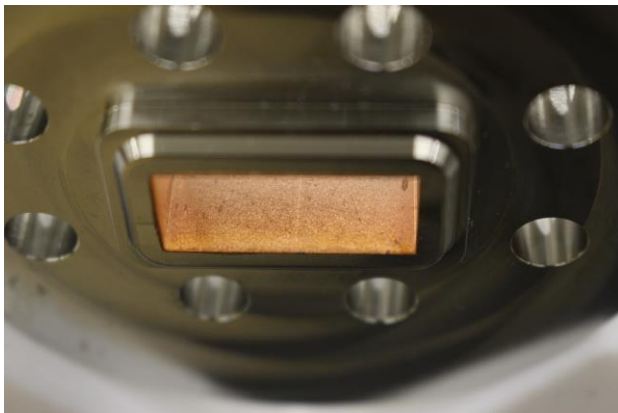
- Diffusion bonding and brazing with a protective H<sub>2</sub> atmosphere.
- High vacuum <math><10^{-5}</math> mbar; >15% H<sub>2</sub>; > 1000 °C
- Qualification of the oven involving pollution tests and an observation with scanning electron microscope
- Bodycote (FR), Reuter (DE), TMD (UK), MHI (JP)
  - Potential extension to vacuum brazing following structure manufacture from PSI
  - Electron-beam-welding of hard copper under investigation



# SURFACE TREATMENT



- **Copper coating on stainless steel.**
- Need to respect dimensioning
- Technology transfer from CERN if needed
- Thermocompact (FR), BACMI (FR), Multivalent (NL, ongoing)



- **Vacuum baking** at  $10^{-8}$  for 1-2 days
- Big furnace
- Bodycote (FR), COMEB (IT), MHI (JP)

*Pumping group*



*Baking oven (outside)*

*Control pane*

*Structure support*

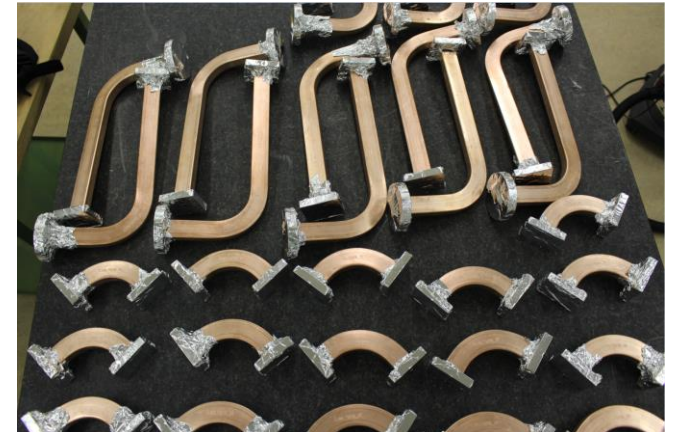
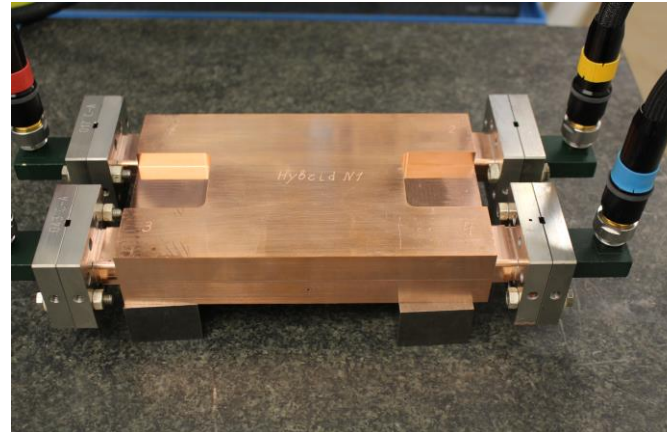
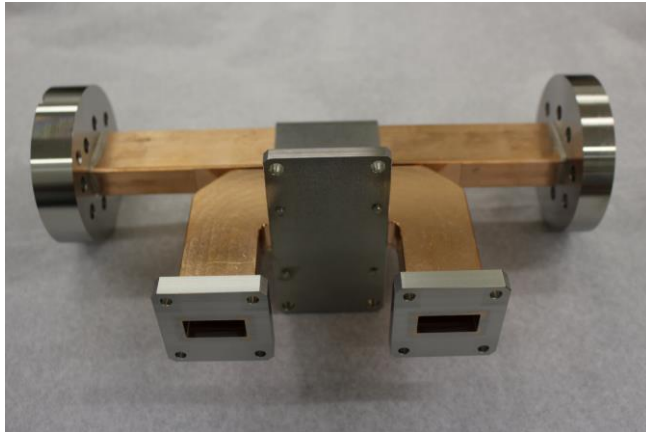


*Baking oven (inside)*



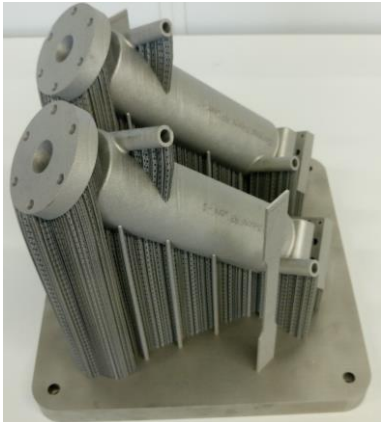
# UHV, RF COMPONENTS

- Traditional machining of copper and stainless steel parts
- Brazing of copper to SS, copper to copper and copper to SiC
- Copper sintering
- Relative small series tested up to 60 MW peak power
- CINEL (IT), VDL (NL), BACMI (FR), CECOM(IT) Reuter (DE), Nihon (JP), COMEB (IT, ongoing), Viztrotech (KR, ongoing)



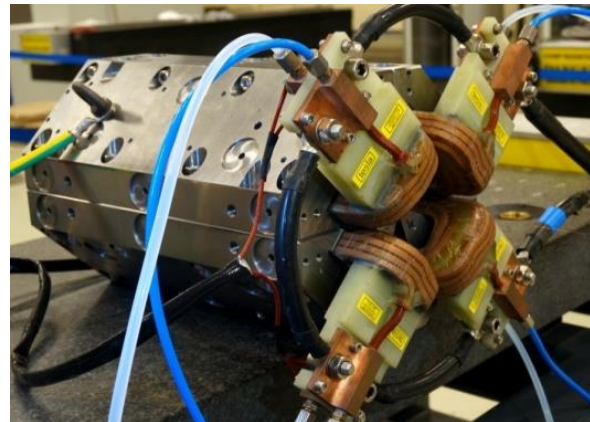
# ADDITIVE MANUFACTURING

- **3D printing in Titanium** for lossy parts like loads or low power components
- Parallel development at CERN and in industry
- SWISStoI2 (CH), 3T RPD (UK), Concept Laser (DE), INITIAL (FR), Protoshop (DE)
- Currently under test for high power operation



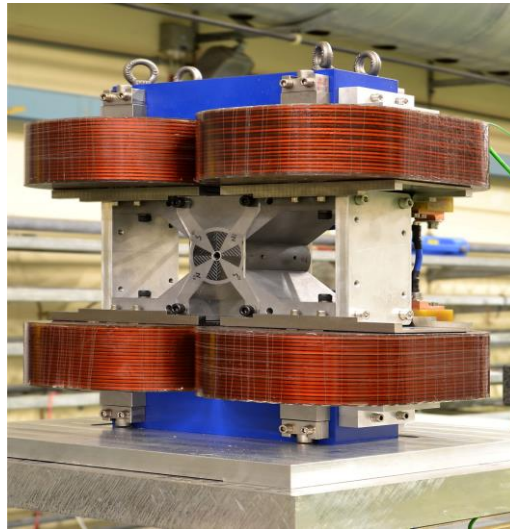
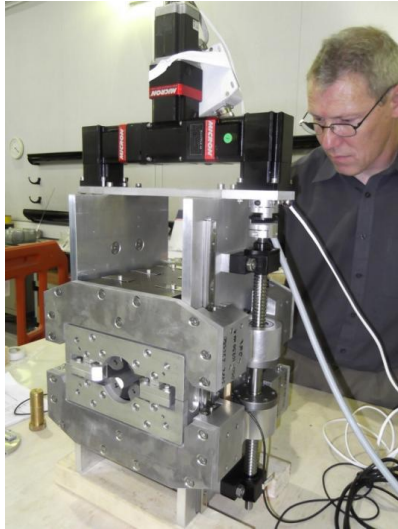
# CONVENTIONAL MAGNETS

- Complete manufacturing Danfysik (DK)
- Procurement and winding of coils, TESLA (UK), S.E.F. (F)
- High Precision quadrants machining DMP (ES), OSTROJ (CZ)
- Iron-yokes lamination laser-cut and packing : LCD (CH)
- Iron Yokes EDM Machining: Röttgers Værktøj (DK)



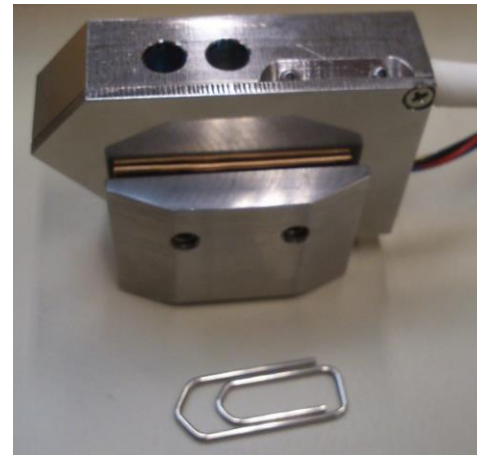
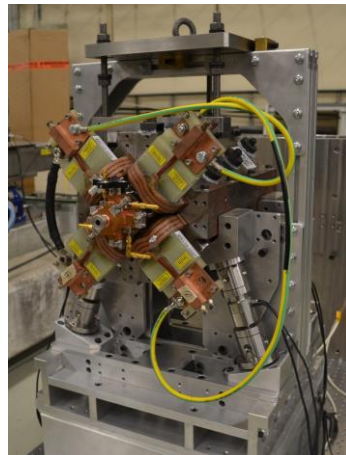
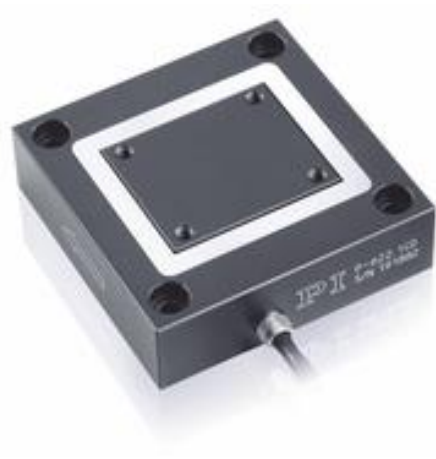
# PERMANENT MAGNETS

- Tuneable permanent magnets in collaboration with Daresbury Laboratory
- PM blocks and Permendur: Vacuumschmelze GmbH & Co. (D), VDL (NL)
- High Precision mechanic components: SENAR (UK), TSW (UK), Group4 ( UK), Mclennan (UK)



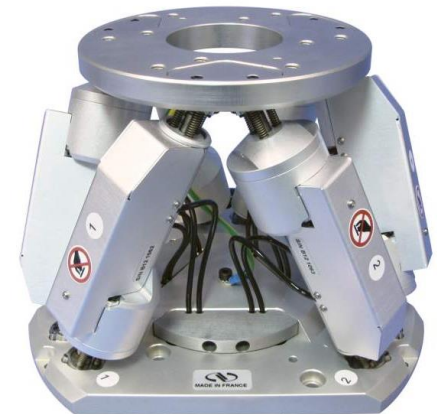
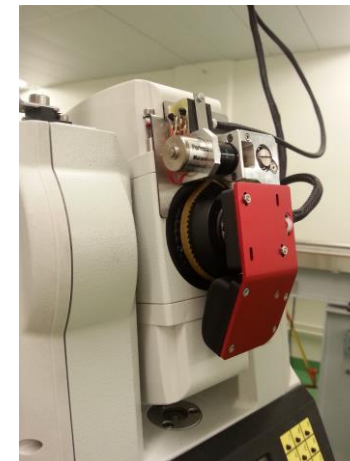
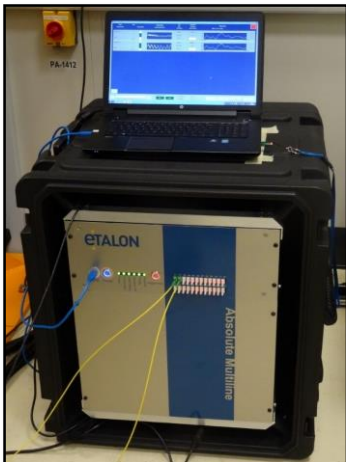
# PRECISION ENGINEERING

- Nano-stabilization and nano-positioning coupled with very high stiffness systems and vibration sensors are necessary in CLIC to guarantee a high beam quality and thus high luminosity
- **Piezo actuators** beyond the state of the art. Prototype qualification required: PI (DE), Heinmade (NL), NOLIAC (DK), Heidenhain (DE), Fagor automation (ES).
- **Sensors, encoders, scales with nanometer resolution:** Renishaw (UK),
- **High precision assemblies:** STTSL (NL), JPE (NL)
- **Vibration sensors** with bandwidth 0.1~200Hz, resolution <math><0.1\text{ nm rms}</math> @1Hz and resistant to magnetic fields and radiation: MI partners (NL), TNO (NL), Silicon audio (US)



# MEDIUM AND LARGE SCALE METROLOGY

- **Coordinate Measuring Machines:** Leitz (DE), Zeiss
- **Laser trackers laser scanner, portable CMM, tacheometer:** Hexagon Metrology/Leica-geosystems (DE, CH), Faro (US)
- **Frequency scanning interferometry systems:** Etalon (DE)
- **Targets and reflectors:** PLX (US), Etalon AG (DE), Leica-geosystems (CH), Thorlabs (US)
- **Alignment systems:** Fogale Nanotech (FR), Queensgate (UK), micro-epsilon (DE)
- **Adjustment systems, linear actuators, cam movers :** ZTS vvu Kosice (SK)
- **Tables, stages:** PI (DE), Dyneos (CH), Aerotech (UK), Newport (US)



# PULSED KLYSTRONS



CPI (US)VKX-8311A @ 11.9942 GHz  
50 MW peak power, 1.5  $\mu$ s pulse length  
50 Hz rep. rate

Based on SLAC XL5 klystron  
developed by SLAC from SLS XL4

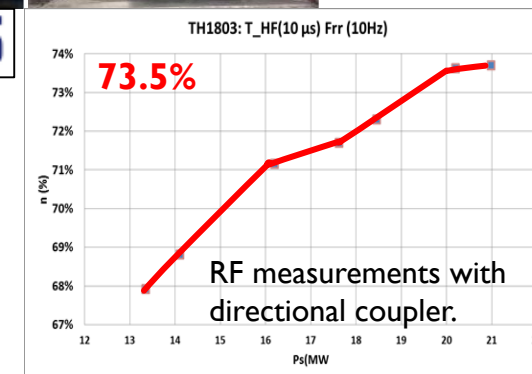


TOSHIBA (JP) E37113 @ 11.9942 GHz  
6 MW peak power, 5  $\mu$ s pulse length  
400 Hz rep. rate  
Developed by Toshiba on CERN contract



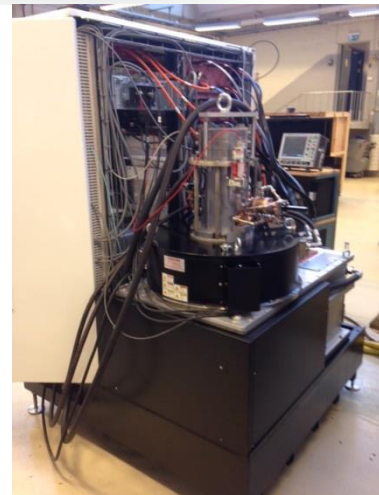
THALES

THALES (FR) MBKTH1803 @ 1.0 GHz  
21 MW peak power, 10  $\mu$ s pulse length  
10 Hz rep. rate  
Developed by THALES on CERN contract



# MODULATORS

- High Voltage Pulsed modulators.
- Maximum pulse voltage ripple 0.25%
- Pulse to pulse stability 0.1%
- Scandinova (SE) modified K1 and K2 modulators for Xboxes
- ETH-Zurich development in collaboration with CERN for drive beam.
- Pulse transformer built by Pikatron (CH)

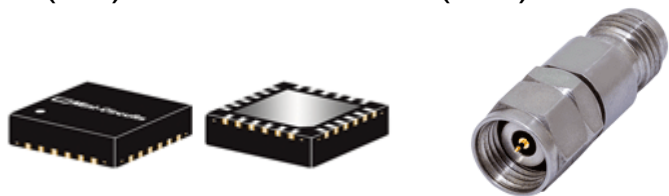


# RF DRIVERS, DIAGNOSTICS AND LLRF

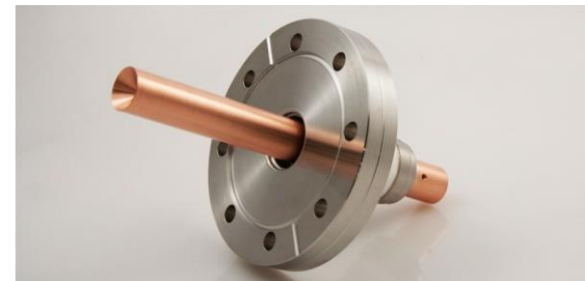
New **Solid State Amplifier** 400 W AM61-12S-60-56-PR  
SN001 by Microwave Amps (UK)  
Two new units at 1 kW!



Other LLRF components like filters, power  
splitters, isolators, attenuators etc  
Mini-circuits (US), Techniwave (FR), Marki  
Microwave (US), Huber Shuner (CH),



Radiabeam (US)  
**faraday cups**

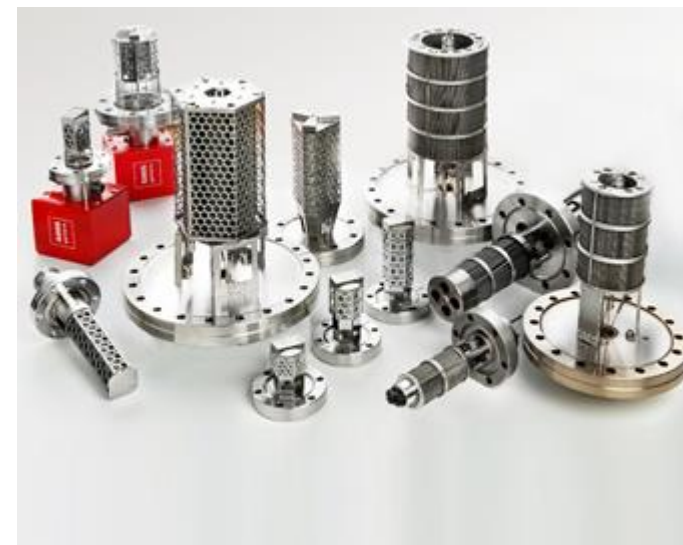


Killerbee **high  
stability RF cables**  
from Megaphase (US)

**Ceramics** for RF and ultra high vacuum  
Ceratec (NL), Micropierre (FR), Andalo Giani (IT),  
Friatec (DE)

# VACUUM TECHNOLOGY

- Vacuum pumps
- Vacuum valves and gauges
- UHV tubes, bellows and connections
- SAES (IT), VAT (CH), CECOM (IT)



# ANTICIPATING YOUR QUESTIONS

- CLIC has now proven the technology is ready by prototyping in the past 10 years.
- Solutions are still hard to implement and some need work to be produced
- Many solutions are at the limit of what can be done
- Project implementation plan covers industrialization
  - Design for cost
  - Technology transfer
- For 2020 to 2025 we expect some small series of still very sophisticated items.
  - Many technologies have not been mentioned
  - You may not know what we do or want to do
    - We may not know what you can do



Thanks!!





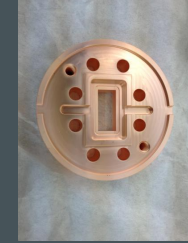
Bodycote (FR)  
Reuter (DE)  
TMD (UK)



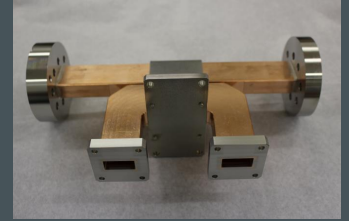
SWISSto12 (CH)  
3T RPD (UK)  
Concept Laser (DE)  
INITIAL (FR)  
Protoshop (DE)



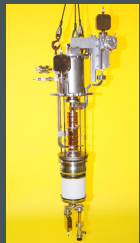
VDL (NL)  
LT-Ultra (DE)  
Yvon Boyer (FR)  
DMP (ES)  
Morikawa (JP)  
KERN (DE)



Thermocompact (FR)  
BACMI (FR)  
Multivalent (NL)



CINEL (IT)  
VDL (NL)  
BACMI (FR)  
CECOM(IT)  
Reuter (DE)  
Nihon (JP)  
COMEB (IT)  
Viztrotech (KR)



Thales (FR)  
CPI(US)  
Toshiba (JP)



Scandinova (SE)  
Jema (ES)  
Picatron (CH)



Compact Linear Collider